IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN THE MATTER OF:

Jaehwan EUN, et al.

CONFIRMATION NO.: 1957

FILED: June 17, 2005

GROUP ART UNIT:

SERIAL NO. 10/539,883

EXAMINER:

FOR: Method For Preparation of Ferroelectric Single Crystal Film Structure Using

Deposition Method

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

SIR:

This Information Disclosure Statement is being filed in accordance with the provisions of 37 CFR 1.97 before the issuance of a first Office Action. However, any required fees in the prosecution of this application should be deducted from Deposit Account No. 503814.

The Information Disclosure Statement is being filed to officially make of record the references, with English abstracts thereof, cited in the attached PTO/SB/08A attached hereto.

Respectfully submitted,

Attorney for Applicant

Dated: March 14, 2007

Eugéne Lieberstein Registration No. 24,645

CUSTOMER NO.: 01109

MAILING CERTIFICATE

I hereby certify that this IDS w/References & English abstracts, is being deposited with the Commissioner For Patents, P.O. Box 1450, Alexandria, VA 22313-1450 via EFS-Web on March /3, 2007.

Audry de by Audrey de Souza

Approved for use through 03/31/2007. OMB 0651-0031

U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE
Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

Complete if Known Substitute for form 1449/PTO Application Number 10/539,883 Filing Date June 17, 2005 INFORMATION DISCLOSURE First Named Inventor Jaehwan EUN, et al. STATEMENT BY APPLICANT Art Unit (Use as many sheets as necessary) Examiner Name Attorney Docket Number | DE1642

of 1

Sheet 1 U. S. PATENT DOCUMENTS Pages, Columns, Lines, Where Publication Date Name of Patentee or Document Number Examiner Cite Relevant Passages or Relevant MM-DD-YYYY Applicant of Cited Document initials* Figures Appear Number-Kind Code^{2 (If known)} US-ับร-US-US-US-US-US. US-US-US-US-US-US-HS-US-US-US-US-US-

		FORE	IGN PATENT DOCU	IMENTS		
Examiner Initials*	Cite No. ¹	Foreign Patent Document	ign Patent Document Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear	
		Country Code ^a "Number ^a "Kind Code ⁵ (# known)				T
		JP 2000-068455 A	03-03-2000	Nippon Electric Co.		<u> </u>
		CN 1362749A	08-07-2002	Shanghai Inst of Technolo		¥
		CN 1379460 A	11-13-2002	Univ Nanjing (CN)		V
						-
						<u> </u>
	1					

Examiner	Date	
Signature	Considered	

*EXAMINER: initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through considered. Include copy of this form with next communication to applicant. *Applicant's unique citation designation number (optional). *See Kinds Codes of USPTO Patent Documents at www.issin.com or MPEP 901.04. *Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). *For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. *Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. *Applicant is to place a check mark here if English language

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.